

PATENT
81784.0329

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiji KAI et al.

Serial No: 10/533,030

Filed: April 26, 2005

For: Method for Manufacturing Micro
Lenses including Underlayer Film
and Lens Film Etching Steps (as
amended)

Art Unit: 2818

Examiner: Lopez Esquerra, Andres

I hereby certify that this correspondence is
being transmitted via electronic filing to:
Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450 on
August 29, 2008
Date of Deposit
Nancy Nolen
Name

Signature 08/29/2008
Date

PETITION FOR EXTENSION OF TIME

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the
Commissioner for a one-month extension of time extending to August 29, 2008, the
period for response to the final Office Action dated April 29, 2008. Please charge
the fee of \$120.00 for this extension to Deposit Account No. 50-1314. The
responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account
No. 50-1314.

Respectfully submitted,


HOGAN & HARTSON L.L.P.

By:


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Date: August 29, 2008

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